electronic material and a functional material.
Claims:

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- 1. A process for producing a single-walled carbon nanotube by a vapor deposition technique, comprising:
- a step of spraying a solution prepared by dissolving an organic metal compound in an organic solvent into a furnace of a rare gas atmosphere,
- a step of vaporizing the organic metal compound and the organic solvent each described above by heating the sprayed solution,
- a step of heating and decomposing the vaporized organic metal compound to obtain metal and heating and decomposing the vaporized organic solvent with the metal described above being used as a decomposition catalyst to obtain carbon atoms and
- a step of growing a graphene sheet using the carbon atoms obtained.
- 2. The process for producing a single-walled carbon nanotube as described in claim 1, wherein a pressure in the furnace is controlled to 760 Torr or less.
 - 3. The process for producing a single-walled carbon nanotube as described in claim 2, wherein a pressure in the furnace is controlled to 500 Torr or less.

4. The process for producing a single-walled carbon nanotube as described in any of claims 1 to 3, wherein the organic solvent is alcohol.

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- 5. The process for producing a single-walled carbon nanotube as described in claim 4, wherein the alcohol is ethanol.
- 10 6. The process for producing a single-walled carbon nanotube as described in any of claims 1 to 5, wherein the organic metal compound is metallocene.
- 7. The process for producing a single-walled carbon nanotube as described in claim 6, wherein the metallocene is ferrocene.
 - 8. The process for producing a single-walled carbon nanotube as described in any of claims 1 to 7, wherein the organic metal compound contained in the solution prepared by dissolving the organic metal compound in the organic solvent has a concentration of 0.01 to 1 mass %.
- 9. The process for producing a single-walled carbon nanotube as described in any of claims 1 to 8, wherein

the solution described above which is pressurized by an inert gas having a back pressure of 100 to 1000 Torr is sprayed through a nozzle having an aperture diameter of 0.01 to 1 mm.

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10. The process for producing a single-walled carbon nanotube as described in any of claims 1 to 9, wherein a heating temperature for vaporizing the organic solvent and the organic metal compound is 50 to 600°C.

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11. The process for producing a single-walled carbon nanotube as described in claim 10, wherein a heating temperature for vaporizing the organic solvent and the organic metal compound is 100 to 400°C

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12. The process for producing a single-walled carbon nanotube as described in any of claims 1 to 11, wherein a heating temperature for heating and decomposing the organic solvent and the organic metal compound is 550 to 1000°C.

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13. The process for producing a single-walled carbon nanotube as described in claim 12, wherein a heating temperature for heating and decomposing the organic solvent and the organic metal compound is 700 to 1000°C.

14. The process for producing a single-walled carbon nanotube as described in any of claims 1 to 13, wherein a temperature for growing the graphene sheet is lower than a temperature of heating the organic solvent.

15. The process for producing a single-walled carbon nanotube as described in any of claims 1 to 14, wherein the inert gas is argon or helium.

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16. The process for producing a single-walled carbon nanotube as described in any of claims 1 to 15, wherein 5 mass % or less of hydrogen gas is mixed with the inert gas.

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17. The process for producing a single-walled carbon nanotube as described in any of claims 1 to 16, wherein the single-walled carbon nanotube comprising the grown graphene sheet is collected by a membrane filter.

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18. Equipment for producing a single-walled carbon nanotube by a vapor deposit technique, comprising:

a nozzle for spraying a solution prepared by dissolving an organic metal compound in an organic solvent by pressurizing with an inert gas having a

prescribed back pressure,

a pre-heating part for vaporizing the organic metal compound and the organic solvent each described above by heating the sprayed solution,

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a main heating part for heating and decomposing the organic metal compound vaporized in the pre-heating part and heating and decomposing the organic solvent vaporized in the pre-heating part with the metal obtained by heating and decomposing the organic metal compound being used as a catalyst,

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a growing part for growing a graphene sheet using carbon atoms obtained by heating and decomposing the solvent described above in the main heating part,

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a first controlling means for heating and maintaining a temperature of the furnace in the preheating part described above at 50 to 600° C,

a second controlling means for heating and maintaining a temperature of the furnace in the main heating part described above at 550 to 1000°C and

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a third controlling means for maintaining the preheating part, the main heating part and the growing part in a rare gas atmosphere.